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TC 1700

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicant(s): Hidemitsu Aoki, et al.

Examiner: Saeed Chaudhry

Serial No.: 10/075,566

Art Unit: 1746

Filed: February 13, 2002

Docket: 12688A

For: METHOD FOR CLEANING
SEMICONDUCTOR WAFER AFTER
CHEMICAL MECHANICAL POLISHING
ON COPPER WIRING

Dated: December 15, 2003

Commissioner for Patents
Mail Stop Non-Fee Amendment
Arlington, VA 22313

RESPONSE PURSUANT TO 37 C.F.R. §1.115

Sir:

In response to the office action of October 7, 2003, the applicants submit the following response.

CERTIFICATE OF MAILING UNDER 37 C.F.R. §1.8(a)

I hereby certify that this correspondence is being deposited with the United States Postal Service as first class mail in an envelope addressed to: Commissioner for Patents, M.S. Non-Fee Amendment, Arlington, VA 22313 on December 15, 2003.

Dated: December 15, 2003


Richard J. Danyko

AMENDMENT TRANSMITTAL LETTER (Large Entity)

Applicant(s): Hidemitsu AOKI, et al.

Docket No.

12688A

Serial No.
10/075,566Filing Date
February 13, 2002Examiner
Saeed ChaudhryGroup Art Unit
1746Invention: METHOD FOR CLEANING SEMICONDUCTOR WAFER AFTER CHEMICAL MECHANICAL
POLISHING COPPER WIRING

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TO THE COMMISSIONER FOR PATENTS:

DEC 29 2003

Transmitted herewith is an amendment in the above-identified application.

TC 1700

The fee has been calculated and is transmitted as shown below.

CLAIMS AS AMENDED

	CLAIMS REMAINING AFTER AMENDMENT	HIGHEST # PREV. PAID FOR	NUMBER EXTRA CLAIMS PRESENT	RATE	ADDITIONAL FEE
TOTAL CLAIMS	42 -	42 =	0	x \$18.00	\$0.00
INDEP. CLAIMS	4 -	4 =	0	x \$86.00	\$0.00
Multiple Dependent Claims (check if applicable)	<input type="checkbox"/>				\$0.00
		TOTAL ADDITIONAL FEE FOR THIS AMENDMENT			\$0.00

No additional fee is required for amendment.

Please charge Deposit Account No. in the amount of .

A check in the amount of to cover the filing fee is enclosed.

The Director is hereby authorized to charge payment of the following fees associated with this communication or credit any overpayment to Deposit Account No. 19-1013/ssmp

Any additional filing fees required under 37 C.F.R. 1.16.

Any patent application processing fees under 37 CFR 1.17.

Signature

Dated: December 15, 2003

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RJD/ej

CC:

I certify that this document and fee is being deposited on Dec. 15, 2003 with the U.S. Postal Service as first class mail under 37 C.F.R. 1.8 and is addressed to the Commissioner for Patents, P.O. Box 1450, Alexandria, VA 22313-1450.

Richard J. Danyko

Typed or Printed Name